

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re patent application of

Hideki Tanaka

Serial No.: 09/788,503

Filed: February 21, 2001

Group Art Unit: 2823

Examiner: Nguyen, Khiem D.

For: TAPE CARRIER TYPE SEMICONDUCTOR DEVICE, METHOD FOR  
MANUFACTURING THE SAME, AND FLEXIBLE SUBSTRATE



Honorable Commissioner of Patents  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents, cited in the Japanese Office Action and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

In compliance with the requirements of 37 CFR §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of portions of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country of the United States relative to the subject matter claimed in the present application has been made, the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

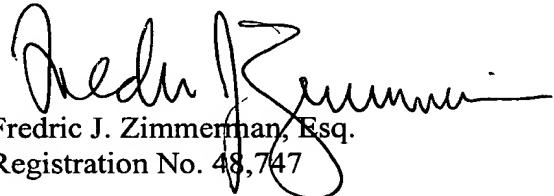
I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

Submitted herewith is a check in the amount of \$180.00 to cover the IDS fee.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

  
Fredric J. Zimmerman, Esq.  
Registration No. 48,747

Date: 4/8/04  
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**INFORMATION DISCLOSURE CITATION**  
*(Use several sheets if necessary)*

*(Use several sheets if necessary)*

Docket Number (Optional)  
**00N033-US**

**Application Number**

**Applicant(s)**  
**Hideki Tanaka**

**Filing Date**      **Group Art U**

**February 21, 2001** | **2823**

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

**OTHER DOCUMENTS**    *(Including Author, Title, Date, Pertinent Pages, Etc.)*

**Japanese Office Action dated January 13, 2004, with partial English translation.**

EXAMINER

**DATE CONSIDERED**

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.